

Application/Control No.	Applicant(s)/Patent under Reexamination		
10/522,772	FUNAHATA ET AL.		
Examiner	Art Unit		
David Y. Chung	2871		

SEARCHED					
Class	Subclass	Date	Examiner		
349	114	5/29/2007	DC		
349	113	5/29/2007	DC		
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INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	
same	same	5/29/2007	DC	
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SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
	DATE	EXMR		
EAST search report	5/29/2007	DC		
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